FORM PTO 1449 (*modified*)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

LIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)

ATTY DOCKET NO.	APPLICATION NO.
03500.014730.1	10/609,421

APPLICANT: HIROSHI OHKURA ET AL.

FILING DATE	GROUP
July 1, 2003	1756

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
KMS	JP	2000-195036	07/14/00	Japan			Abstract
"	JP	10-121292	05/12/98	Japan			Abstract

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KMS		Hideki Masuda et al., "Fabrication of Gold Nanodot Array Using Anodic Porous Alumina as an Evaporation Mask," 35 Jpn. J. Appl. Phys. L126-L129 (1996).
"		O. Jessensky et al., "Self-Organized Formation of Hexagonal Pore Arrays in Anodic Alumina," 72(10) Appl. Phys. Lett. 1173-1175 (March 1998).

EXAMINER: Kevin Berezny — DATE CONSIDERED: 3/17/04

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO 1449 (*modified*) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)	ATTY DOCKET NO. 03500.014730.1	APPLICATION NO. Div. of 09/649,598
	APPLICANT HIROSHI OHKURA ET AL.	
	FILING DATE Herewith	GROUP N.Y.A.

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KMB		5,882,823	03/16/99	Neary	430	5	

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OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER	Kevin M. Bertsch	DATE CONSIDERED	3/17/04

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	APPLICANT HIROSHI OHKURA ET AL.	
	FILING DATE Herewith	GROUP N.Y.A.

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		6,278,231 B1	08/21/01	Iwasaki et al.	313	310	
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HKO		Hutley, M.C. "Coherent Photofabrication", Opt. Eng., Vol. 15, No. 3 (1976), pp. 190-196.
		Decker, et al. "Generating...Reversal," J. Vac. Sci. Technol. B15(6), Nov. 1997 pp. 1949-1953.
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		Masuda, "Anodically ..... High Level"; Solid State Phys. , Vol. 3, No. 5, pp. 493-499 (1996).

EXAMINER Kevin Kustow DATE CONSIDERED 3/17/04

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